

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:  RUDOLF PETER MUIS ET AL.  Serial No.: 10/514,424  Filed: May 26, 2005  For: METHOD AND APPARATUS FOR APPLYING A LAYER OF A SECOND MATERIAL TO A LAYER OF A NANOCRYSTALLINE FIRST MATERIAL	Confirmation No. 8641  Art Unit: 1792  Examiner: ROLLAND, ALEX A.
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**AMENDMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION**

Mail Stop: AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed on December 11, 2008, please amend the above-identified application as set forth below.

A Petition for a Three-Month Extension of Time fee is believed to be due, as detailed in the attached documents. However, any further extension of time necessary to prevent abandonment is hereby requested, and any fee necessary for consideration of this response is hereby authorized to be charged to Deposit Account Number 50-2613.

**Amendments to the Claims:** reflected in the list that begins on page 2 of this paper.

**Remarks:** begin on page 7 of this paper.